



41  
Docket No.: 60188-419

1756  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Shigeo IRIE

Serial No.: 09/891,192

Filed: June 26, 2001

For: PATTERN FORMING METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE

: Customer Number: 20277  
:  
: Confirmation Number: 9324  
:  
: Group Art Unit: 1756  
:  
: Examiner: Saleha Mohamedulla  
:

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OCT 31 2003  
TC 1700

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	21	21	0	\$18.00 =	\$0.00
Independent Claims	9	9	0	\$86.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: October 29, 2003

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: Customer No.: 20277

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SEMICONDUCTOR DEVICE

AMENDMENT

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 30, 2003, having a three-month shortened statutory period for response set to expire on October 30, 2003, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.